

PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of: Satya et al.

Attorney Docket No.: KLA1P016F/P642

Application No.: 09/648,095

Examiner: P. Cao

Filed: August 25, 2000

Group: 2811

Title: CHEMICAL MECHANICAL POLISHING TEST STRUCTURES AND METHODS FOR

INSPECTING THE SAME

CERTIFICATE OF MAILING

I hereby certify that this correspondence is being deposited with the U.S. Postal Service with sufficient postage as first-class mail on May 29, 2003 in an envelope addressed to the Commissioner for Patents, P.O. Box 1450 Alexandria, VA 22313-1450

Signed:

Nutaree Morgan

Natalie Morgan

REQUEST FOR RECONSIDERATION (AMENDMENT B)

Mail Stop Non-Fee Amendment Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Dear Sir:

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JUN-4 2003

TECHNOLOGY CENTER

It is respectfully submitted that the Examiner enters the following remarks is response to the Office Action dated 24 April 2002, a response to which is due on 24 July 2003.